

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/771,972	ISHIYAMA ET AL.	
Examiner	Art Unit	
Nabil M. El-Hady	2152	

SEARCHED					
Class	Subclass	Date	Examiner		
709	202 217				
	218				
	226	į,			
	228				
	230	7/28/45	NE		
	232				
	245				
370	400				
	389				
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455	433				
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INTERFERENCE SEARCHED							
Class	Subclass	Date	Examiner				
Same	As Senr	had 7/27/0	- NE				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
West Search West Results	7/22/05	NE
NPL (IEEE)		